

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First inventor: Ian C. Mayes

Assignee: Nanometrics Incorporated

Title: Monitoring Apparatus And Methods For Improving The Accuracy And Repeatability Of Electrochemical Capacitance Voltage (ECV) Measurements

Serial No.: 10/520,439 Filing Date: April 5, 2006

Examiner: Robert J. KASTEN Group Art Unit: 4191

Docket No.: NAN143 US 8016 Confirmation No: 5914

Saratoga, California
April 3, 2009

Mail Stop Amendment:
COMMISSIONER FOR PATENTS
P.O. BOX 1450
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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97(c)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the document listed on the accompanying modified Form PTO/SB/08. A copy of the document is also submitted herewith. The Examiner is requested to make the listed document of record.

This Supplemental Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(b) as it is within three months of the filing date of a national application other than a continued prosecution application and/or before the mailing of a first Office Action on the merits. Accordingly, no fee is required.

Applicants would appreciate the Examiner initialing and returning the Form PTO/SB/08, indicating that the information has been considered and made of record herein.

The information contained in this Supplemental Information Disclosure Statement is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by

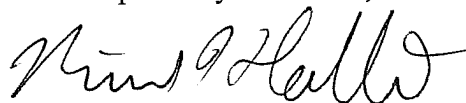
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third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Michael J. Halbert", written in a cursive style.

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